In re the Application of: WATANABE, Kenichi Group Art Unit: 2815

Serial No.: 10/050,171 Examiner: WARREN, Matthew E.

Filed: January 18, 2002 P.T.O. Confirmation No.: 7623

For. SEMICONDUCTOR DEVICE CAPABLE OF SUPPRESSING CURRENT CONCENTRATION IN PAD AND ITS MANUFACTURE METHOD

## **PRELIMINARY AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is a Preliminary Amendment for the above-captioned patent application. Please amend the above-captioned patent application as follows:

Date: June 8, 2007

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.